SNU application for membership in ePIC

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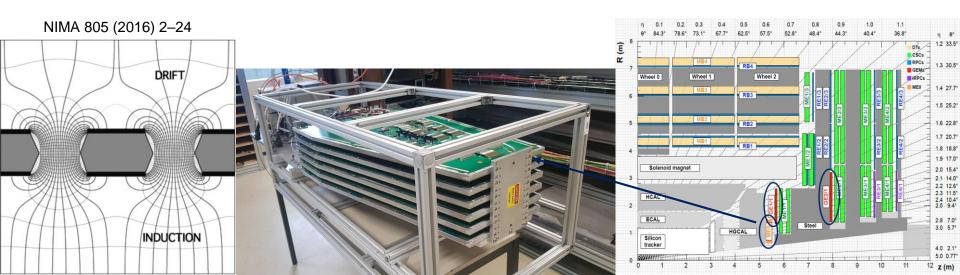
ePIC Collaboration Council @ Monte Porzio Catone (RM)



Contents

- Expertise of SNU on MPGD production
- GEM foils production for CMS Phase-2 upgrades
- Contribution plan toward GEM + μ RWELL ECT
 - μ RWELL R&D status
 - Budget status
- Person power

- CMS phase-2 upgrades
- Three GEM stations: GE1/1, GE2/1 & ME0
- Too many GEM foils for CERN micro pattern workshop (MPT) produce alone
- → Korea CMS group (KCMS): production of half of GE2/1 and ME0 foils ~ 1100 foils
- As a member of KCMS, SNU is leading R&D for GEM foil production & aging and mass production



- Along with KCMS technicians, I developed the GEM foil production process and validated the produced GEM foils
- 2023 JINST **18** C06010
- NIMA 1057 (2023) 168723
- → Green light from CMS
- Currently, mass production of ME0 is ongoing smoothly
- It is expected to be completed by the end of this year
- Maximum size: $120 \times 58 \ cm^2$ Double-mask technique & glass mask







2. Contribution plan for ECT

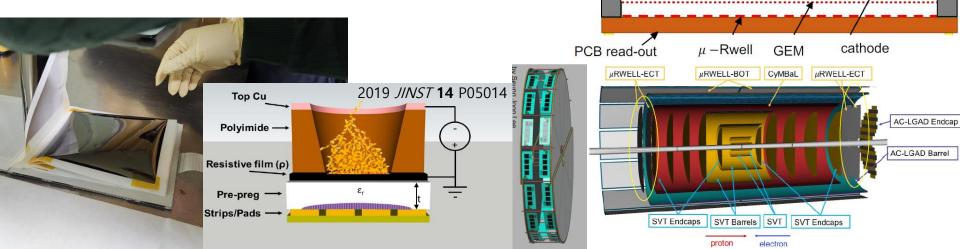
- We hope to provide in-kind contributions of GEM foils and μ RWELL PCBs for ECT production
- We can help alleviate the MPGD procurement burden that the ePIC experiment is also experiencing
- To provide person power for detector assembly and integration
- Because μ RWELL is resistive variant of GEM foils, those share most of production process

3 mm honeycomb

3 mm gas gap

- Had a meeting with Rui to secure production know-how

- Production of $10\times 10~cm^2~\mu {\rm RWELL}$ is ongoing to check production feasibility



2. Contribution plan for ECT

- Ministry of Science and ICT, National Research Foundation, and physics community are very supportive of this plan
- 1.4 2.1 M USD is quite likely to be allocated starting next year
- By utilizing the existing equipment and trained personnel, it is possible to provide in-kind contributions for ECT with a modest budget
- SNU is already maintaining close contact with Kondo and Annalisa regarding the GEM foils and μ RWELL PCB for the ePIC

3. Person Power



- Seonho Choi (SNU)
- Professor
- Expert of Physics which will be studied by ePIC



- Inseok Yoon (SNU, KCMS)
- Senior researcher
- 2-3 Ph.D Students



- Yeonggun Jeong (KCMS)
- Technician



- Seongho Park (KCMS)
- Technician

- External Contractors
- PI etching
- FCCL gluing
- DLC sputtering

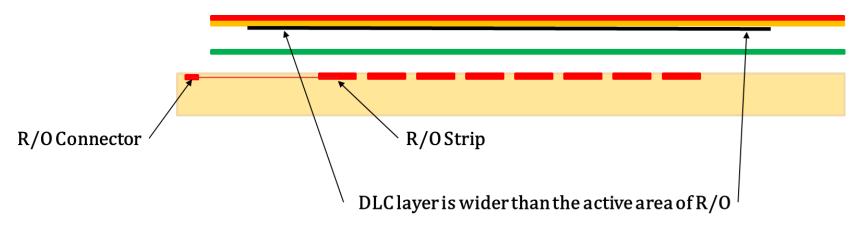
Summary

- SNU would like to join the ePIC experiment
- During the construction phase, SNU is willing to contribute GEM and μ RWELL for ECT production as in-kind and provide person power for detector assembly and integration
- Budget for this contribution is very likely
- SNU is a proven producer of GEM foils and expanding capability to $\mu RWELL$
- Since $\mu RWELL$ is a resistive variant of GEM, it shares technical similarities with GEM
- Now SNU has an appropriate structure and become fully online

Back Up

2. Production processes

 The DLC layer is formed by a sputtering process and are procured by ordering it from CERN or other suppliers

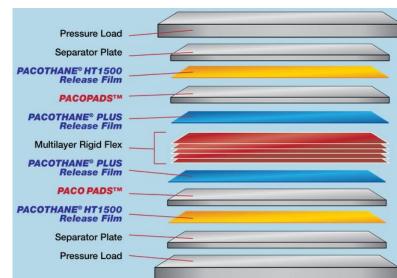


• Pressing DLC FCCL, pre-preg and RO PCB at high temperature in a vacuum

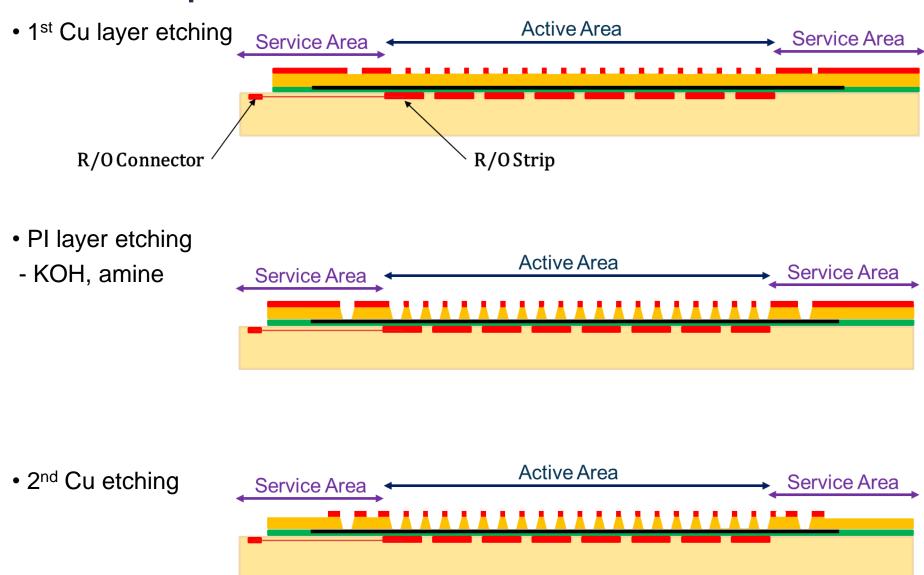
chamber

- Will be done by PCB maker

- Common PCB pressing process, but requires know-how to construct "stack" to control the flatness issue

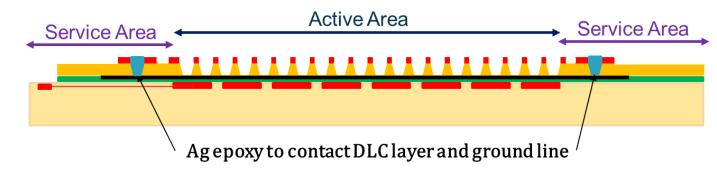


2. Production processes



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Ag epoxy pasting



- Soldering connectors and cleaning
- C-cleaning & E-cleaning needs lots of know-how
- We have the know-how through KCMS GEM production

